

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

**Confirmation No.: 5700**

Katsuhiko MIYA, et al.

Date: January 15, 2008

Serial No.: 10/659,213

Group Art Unit: 1746

Filed: September 10, 2003

Examiner: Jason Mark HECKERT

For: SUBSTRATE PROCESSING APPARATUS

---

**VIA EFS-WEB**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**SUBMISSION**

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart Japanese application dated October 16, 2007 and that this communication, to the best of applicant's knowledge, was not received by any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of this Submission.

In the event the any actual fee is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
THROUGH THE UNITED STATES  
PATENT AND TRADEMARK OFFICE  
EFS FILING SYSTEM  
ON JANUARY 15, 2008



MAX MOSKOWITZ

Registration No.: 30,576

OSTROLENK, FABER, GERB & SOFFEN, LLP  
1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700